

Notice of References Cited	Application/Control No. 10/709,563	Applicant(s)/Patent Under Reexamination GIBBS ET AL.	
	Examiner Roberts Culbert	Art Unit 1763	Page 1 of 1

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*	B	US-4,020,762	05-1977	Peterson, John O. H.	430/302
*	C	US-5,596,912	01-1997	Laurence et al.	76/107.1
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NON-PATENT DOCUMENTS

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	U	Kohler, Michael "Etching in Microsystem Technology" pp.13-17 and 116-117. Wiley-VCH, 1999.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.